PATENT

Attorney Docket No. 040008-0307318

Client Reference: OG03-022

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

JAE WON HAN

Application No.:

Confirmation

No:

Filed:

December 30, 2003

Group No.:

Examiner

For:

METHOD OF FABRICATING METAL INTERCONNECTION OF SEMICONDUCTOR

DEVICE

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

APPLICATION DATA SHEET 37 C.F.R. § 1.76

BIBLIOGRAPHIC DATA

1. Applicant information

First applicant: JAE WON HAN Citizenship: Republic of Korea

Residence: Bucvheon-si, Gyeonggi-do, Korea

2. Correspondence information

Correspondence for this application should be addressed as follows:

Customer No.: 00909

3. Application information

Title of Invention: METHOD OF FABRICATING METAL INTERCONNECTION OF SEMICONDUCTOR DEVICE

Docket number assigned to this application: 040008-0307318

Suggested Classification: Class:

Subclass:

Technology Center to which subject matter is assigned:

Total number of drawing sheets: 3

Type of application: Utility

Application is to be published. Suggested drawing figure for publication:

Secrecy order under § 5.2:

This application does not disclose subject matter of an application which is under a secrecy order pursuant to § 5.2.

4. Representative information

The following have a power of attorney or authorization of agent in this application:

Customer No.: 00909

5. Foreign priority information

Foreign priority is claimed for this application as follows:

Country: Republic of Korea

Application No.: 10-2003-0052945

Filing Date: July 31, 2003

Status: Pending

6. Assignee information

The assignee(s) of this application is/are:

Anam Semiconductor Inc. 891-10 Daechi-dong, Gangnam-gu Seoul, 135-523

Korea

Extent of interest of assignee in application: 100%

Date: December 30, 2003

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P.O. Box 10500 McLean, VA 22102 Customer No. 00909 Signature of Practitioner

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